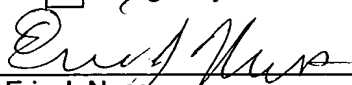




IFW

AMENDMENT TRANSMITTAL LETTER			Docket No. 8733.857.00		
Application No. 10/608,100	Filing Date June 30, 2003	Examiner Stephen G. Sherman	Art Unit 2674		
Applicant(s): Hong Chul KIM					
Invention: ALIGNING METHOD UNDER ELECTRIC FIELD FOR FERROELECTRIC LIQUID CRYSTAL AND LCD USING THE SAME					
TO THE COMMISSIONER FOR PATENTS					
Transmitted herewith is an Amendment and Response to Non-Final Office Action in the above-identified application.					
The fee has been calculated and is transmitted as shown below.					
CLAIMS AS AMENDED					
	Claims Remaining After Amendment	Highest Number Previously Paid	Number Extra Claims Present	Rate	
Total Claims	27	- 20 =	0	x	\$0
Independent Claims	3	- 3 =	0	x	\$0
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					
Other fee (please specify):					
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT:					\$0
<input checked="" type="checkbox"/> Large Entity <input type="checkbox"/> Small Entity					
<input checked="" type="checkbox"/> No additional fee is required for this Amendment and Response to Non-Final Office Action.					
<input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of \$ _____. A duplicate copy of this sheet is enclosed.					
<input type="checkbox"/> A check in the amount of \$ _____ to cover the filing fee is enclosed.					
<input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.					
<input checked="" type="checkbox"/> The Director is hereby authorized to charge and credit Deposit Account No. <u>50-0911</u> as described below. A duplicate copy of this sheet is enclosed.					
<input checked="" type="checkbox"/> Credit any overpayment.					
<input checked="" type="checkbox"/> Charge any additional filing or application processing fees required under 37 CFR 1.16 and 1.17.					
 Eric J. Nuss Attorney Reg. No.: 40,106			Dated: <u>December 12, 2005</u>		



Docket No. 8733.857.00
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
Hong Chul KIM

Customer No. 30827

Application No. 10/608,100

Confirmation No. 8090

Filed: June 30, 2003

Art Unit: 2674

For: ALIGNING METHOD UNDER ELECTRIC
FIELD FOR FERROELECTRIC LIQUID
CRYSTAL AND LCD USING THE SAME

Examiner: Stephen G. Sherman

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

AMENDMENT AND RESPONSE TO NON-FINAL OFFICE ACTION

Sir:

In response to the Office Action dated September 14, 2005, please amend the patent application identified above as follows:

INTRODUCTORY COMMENTS

Amendments to the Specification begin on page 2 of this paper.

Amendments to the Claims are reflected in the listing of claims which begins on page 3 of this paper.

Remarks begin on page 8 of this paper.